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PTO/SB/08A (10-96)

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Sut	ostitute for form	1449A/PTO		Complete if Known		
				Application Number	10/813,026	
INFOF	RMATION	DISCLOS	SURE	Filing Date	March 31, 2004	
STAT	EMENT B	Y APPLIC	ANT	First Named Inventor	GINSBURG, Eyal	
				Group Art Unit	4742 2817	
(use	as many she	ets as necessa	ary)	Examiner Name	Not yot known Barbara Sur	
	1	of	2	Attorney Docket Number	P-6640-US	

			U.S. PATENT DOCUMENT	S	·
	Cite, No. 1	U.S. Patent Document	Name of Patentee or Applicant	Date of Publication of	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
Examiner initials*		Number Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Cited Document MM-DD-YYYY	
BS	Α	2004/0021191	Bradley	02-05-2004	
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁸ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁹ Applicant is to place a check mark here if English language Translation is attached.

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3				Application Number	10/813,026	1
MES	NFORMATION	DISCLOS	URE .	Filing Date	March 31, 2004	1
STATEMENT BY APPLICANT				First Named Inventor	GINSBURG, Eyal	1
				Group Art Unit	1742 2817	1
	(use as many she	ets as necessa	rry)	Examiner Name	Not yet known Burbara Su	mmor
Sheet	2	of	2	Attorney Docket Number	P-6640-US]

		NON PATENT LITERATURE DOCUMENTS	
xaminer	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	τ².
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		Proceedings, IEEE, Tenth Annual International Workshop on Nagoya, Japan, 26-30	
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		New York, NY, USA, IEEE, USA, 08 December 1996, pp. 95-98	
BS	E	Copy of International Search Report for PCT/US2005/006721, mailed on	
		29 June 2005	
		·	

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ST	ATE	MENT	BY APPLICANT	First Named Inventor	March 31, 2004 GINSBURG, Eyal		
				Group Art Unit			
	(use a	as many she	eets as necessary)	Examiner Name	Not-yet-known Bar	bara Oll	
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		Porous Silico	on Science and Technology Confe	rence, PSST 2002, 10-15 Marci	n 2002, Tenerife, Spain, pp. 1-13		
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